



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

January 6, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG764633684

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

8.14 - 8.17 X 4.95 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

2.02 CARATS

D

VVS 2

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

IGI LG764633684

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

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Inscription(s)

EXCELLENT

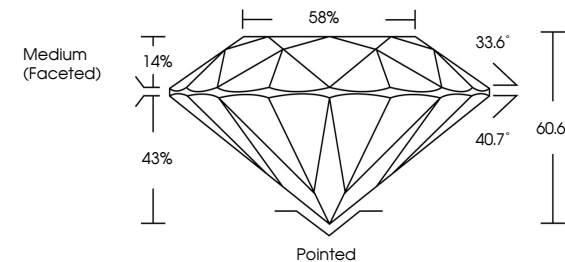
EXCELLENT

NONE

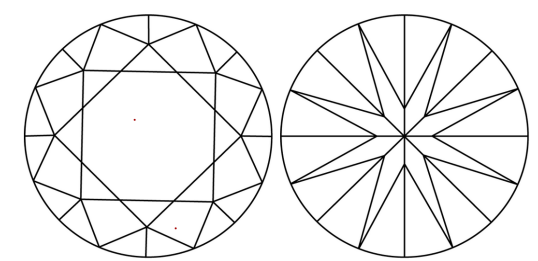
IGI LG764633684

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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ROUND BRILLIANT

8.14 - 8.17 X 4.95 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

2.02 CARATS

D

VVS 2

IDEAL

60.6%

88%

Medium (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG764633684

Cutler

Polish

Symmetry

Fluorescence

Inscription(s)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG764633684

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